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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/523,262	03/03/2005	Takashi Maeda	2005_0059A	8304
	7590 07/09/200 , LIND & PONACK I	EXAMINER		
2033 K. STREE	ET, NW	CAZAN, LIVIUS RADU		
SUITE 800 WASHINGTON, DC 20006			ART UNIT	PAPER NUMBER
			3729	
		MAIL DATE	DELIVERY MODE	
		07/09/2008	PAPER	

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

		Applica	ation No.	Applicant(s)	Applicant(s)			
Office Action Summary			,262	MAEDA ET AL.				
			ner	Art Unit				
		LIVIUS	R. CAZAN	3729				
Period fo	- The MAILING DATE of this commur r Reply	nication appears on	the cover sheet with	n the correspondence ac	ddress			
A SHO WHIC - Exten after: - If NO - Failur Any n	DRTENED STATUTORY PERIOD F HEVER IS LONGER, FROM THE IN sions of time may be available under the provisions SIX (6) MONTHS from the mailing date of this come period for reply is specified above, the maximum s e to reply within the set or extended period for reply sply received by the Office later than three months d patent term adjustment. See 37 CFR 1.704(b).	MAILING DATE OF s of 37 CFR 1.136(a). In no munication. tatutory period will apply and will, by statute, cause the a	THIS COMMUNICA event, however, may a rep d will expire SIX (6) MONTH application to become ABAI	ATION. Ily be timely filed HS from the mailing date of this of NDONED (35 U.S.C. § 133).	•			
Status								
1) 又	Responsive to communication(s) file	ed on 23 <i>April 2008</i>						
·	•	2b)⊠ This action is						
′=		<i>′</i> —		rs. prosecution as to the	e merits is			
•	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.							
Dispositi	on of Claims							
4)🖂	Claim(s) <u>30-32,34,35 and 37-39</u> is/a	are pending in the a	pplication.					
•	4a) Of the above claim(s) is/are withdrawn from consideration.							
	5) Claim(s) is/are allowed.							
	6)⊠ Claim(s) <u>30-32,34,35 and 37-39</u> is/are rejected.							
· ·	Claim(s) is/are objected to.	,						
	Claim(s) are subject to restri	ction and/or election	n requirement.					
Applicati	on Papers							
9)□ -	The specification is objected to by th	e Examiner.						
•	•		b) objected to by	y the Examiner.				
10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner. Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).								
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).								
11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.								
Priority u	nder 35 U.S.C. § 119							
a)[Acknowledgment is made of a claim All b) Some * c) None of: 1. Certified copies of the priority 2. Certified copies of the priority 3. Copies of the certified copies	documents have b	een received. een received in Ap	plication No	Stage			
* S	application from the Internation ee the attached detailed Office action	•		eceived.				
2) Notice 3) Inform	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (Ination Disclosure Statement(s) (PTO/SB/08)	PTO-948)	Paper No(s)/ 5) Notice of Info	mmary (PTO-413) Mail Date ormal Patent Application				
– rapei	No(s)/Mail Date <u>11/14/07</u> .		6)	<u>-</u> ·				

DETAILED ACTION

Continued Examination Under 37 CFR 1.114

1. A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. Applicant's submission filed on 2/25/2008 has been entered.

Claim Rejections - 35 USC § 102

- 2. The text of those sections of Title 35, U.S. Code not included in this action can be found in a prior Office action.
- 3. Claims 30, 31, 34, 35, and 38, and 39 are rejected under 35 U.S.C. 102(b) as being anticipated by Shiyama (JP08083997).

Shiyama discloses a component mounting apparatus comprising: a vacuum generating source (23, Fig. 1); nozzles (14, Fig. 1) connected to said vacuum generating source, each of said nozzles having a control valve capable (21, Fig. 1) of shutting a vacuum air passage (20, Fig. 1); a mounting head (15, Figs. 1 and 2) supported in a movable manner and holding said nozzles; a component recognition device (16, Fig. 2) positioned to face said mounting head for recognizing components held by said nozzles; and a controller (35, Fig. 4) for controlling operations of the component mounting apparatus. Shiyama also discloses using the nozzles, connected to the single vacuum generating device, to perform component pick up operations by picking up components

Application/Control Number: 10/523,262 Page 3

Art Unit: 3729

(5, Fig. 1) and perform component mounting operations by mounting said components onto respective predetermined mounting positions of a circuit substrate (6, Fig. 2); and preventing occurrence of a defective circuit substrate, due to a component failing to be mounted on said circuit substrate, by (i) detecting vacuum pressure decrease of one of said nozzles relative to a vacuum pressure to be achieved at a time of picking up a component by said one of said nozzles, said detecting occurring after the one of said nozzles has passed over a component recognition device; (ii) making a judgment that said one of said nozzles has lost the component due to dropping of the component, if said vacuum pressure decrease of said one of said nozzles exceeds a predetermined first threshold (see para. [0029]), and (iii) skipping a component mounting operation to be performed by said one of said nozzles (see para. [0028]). Clearly, since the detected value is compared to an expected value, an absolute value of the pressure is determined. Moreover, the pressure is checked at various times, and vacuum is shut off at the nozzle if the absolute pressure is higher than a threshold value (see para [0028]). In this manner, mounting is only performed using nozzles that have not dropped a component.

Claim Rejections - 35 USC § 103

- 4. The text of those sections of Title 35, U.S. Code not included in this action can be found in a prior Office action.
- 5. Claims 32 and 37 are rejected under 35 U.S.C. 103(a) as being unpatentable over Shiyama in view of Yamamoto (WO01/43523 with US7065864 being used as an English language equivalent).

Page 4

6. Shiyama discloses the same invention as the Applicant, except for utilizing a recognition camera (imaging device) to identify which of the nozzles has failed to pick up a component based on images obtained by the imaging device (camera). Shiyama does have a recognition station (16, Fig. 2), but it is not clear whether this recognition station is an imaging device (i.e. camera) and Shiyama does not appear to explicitly discuss identifying a nozzle has failed to pick up a component based on data from the recognition station.

- 7. Yamamoto discloses imaging each of the nozzles of a component mounting apparatus with an imaging device (Ref. # 207, col. 14, lns. 21-24) and identifying which nozzle has failed to pick up a component based on the obtained images (col. 14, lns. 42-46) in order to visually determine which nozzle failed to pick up a component, so component mounting step can be skipped (col. 14, lns. 42-46). See Fig. 2.
- 8. At the time the invention was made, it would have been obvious to one having ordinary skill in the art to modify the invention of Shiyama in view of the teachings of Yamamoto, by including using such an imaging device (i.e. camera) as the recognition station, whereby if a component is missing during component recognition, a failed pickup operation is detected. One of ordinary skill in the art would have been motivated to do so in order to detect a failed pickup operation even before executing a pressure checking operation at the recognition station, thereby increasing the operational speed of the apparatus.

Application/Control Number: 10/523,262 Page 5

Art Unit: 3729

Response to Arguments

9. Applicant's arguments with respect to the claims have been considered but are

moot in view of the new ground(s) of rejection.

Conclusion

Any inquiry concerning this communication or earlier communications from the

examiner should be directed to LIVIUS R. CAZAN whose telephone number is

(571)272-8032. The examiner can normally be reached on M-T 6:30AM-5:00PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Peter Vo can be reached on (571)272-4690. The fax phone number for the

organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the

Patent Application Information Retrieval (PAIR) system. Status information for

published applications may be obtained from either Private PAIR or Public PAIR.

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For more information about the PAIR system, see http://pair-direct.uspto.gov. Should

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USPTO Customer Service Representative or access to the automated information

system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

/A. Dexter Tugbang/ Primary Examiner Art Unit 3729

/L. R. C./ 7/7/2008 Examiner, Art Unit 3729